

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Dureseti CHIDAMBARRAO
Group Art Unit : 2813
Appl. No. : 10/715,400
Examiner : J.M. Mitchell
Filed : November 19, 2003
Confirmation No. : 5307
For : SILICON DEVICE ON Si:C-OI AND SGOI AND METHOD OF
MANUFACTURE

AUTHORIZATION TO CHARGE DEPOSIT ACCOUNT

Commissioner for Patents
U.S. Patent and Trademark Office
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401 Dulany Street
Alexandria, VA 22314

Sir :

The undersigned hereby authorizes the U.S. Patent and Trademark Office to charge any fees necessary to maintain the pendency of the above-identified application, including any basic filing fees, application size fees, search fees, examination fees, extension of time fees, and claim fees, to Deposit Account No. 09-0458.

Should the Examiner have any questions, the Examiner is invited to contact the undersigned at the below-listed telephone number.

Respectfully Submitted,
Dureseti CHIDAMBARRAO



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May 8, 2006
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